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PROSECUTION OF THE SUBJECT APPLICATION

Applicants: T.L. Ritzdorf et al. Attorney Docket No. SEMT116048
Application No.: 09/386,734 Group Art Unit: 1742
Filed: August 31, 1999 Examiner: G. Wyszomierski
Title: METHOD AND APPARATUS FOR LOW TEMPERATURE ANNEALING
OF METALLIZATION MICROSTRUCTURES IN THE PRODUCTION OF A
MICROELECTRONIC DEVICE

U.S. PATENT DOCUMENTS

*Examiner

Initial	ID	Document No.	Date	Name
<u>On</u>	U9	5,084,412	01/28/1992	Nakasaki
<u>On</u>	U10	5,674,787	10/07/1997	Zhao et al.
<u>On</u>	U11	5,763,953	06/09/1998	Iijima et al.

Examiner

Date Considered

G Wyszomierski

6/14/01

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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